

Charge Collection in irradiated Si Sensors

- Monitoring the health of the Charge Collection System
- New Parameter: Efficiency Voltage
- Correlation between efficiency and cluster size

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Charge Collection and C-V Measurements in irradiated Si Sensors

- Monitoring the health of the Charge Collection System
- New Parameter: Efficiency Voltage
- Correlation between efficiency and cluster size
- Admittance Measurement

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Fluence in the sATLAS Tracker "du jour"





Design fluences for sensors (includes 2x safety factor) : B layer (r=3.7 cm) $2.5*10^{16}$ neg/cm² 1140 MRad Innermost Pixel Layer (r=5cm): $1.4*10^{16}$ neq/cm² 712 MRad $7.8*10^{15} \text{ neg/cm}^2$ 2nd Pixel Layer (r=7cm): 420 MRad $3.6*10^{15} \text{ neq/cm}^2$ Outer Pixel Layers (r=11cm): 207 MRad $6.8*10^{14} \text{ neq/cm}^2$ Short strips (r=38cm): 30 MRad $3.2*10^{14} \text{ neg/cm}^2$ Long strips (r=85cm): 8.4 MRad

to neutrons+pions

Towards Commercialization of P-type







Charge Collection System

Measurement of collected charge with min. ion. particles (MIPs) combines all effects of radiation damage: depletion voltage increase, inversion, trapping...

CCE System is beta source (⁹⁰Sr) with trigger from single thick scintillation counter. Measurements carried out in freezer at low temperature (-30 °C)





Binary readout with 100 ns shaping time Positive and negative charge readout

Accelerated Annealing at elevated temperature (60°C): about 440 times faster than at RT: 1000 min @ 60°C = 305 days at RT Activation energy E = 1.28 eV (Ziock et al. 1994) Annealing important for thermal management. SCIPP

Collected Charge: CCE





Collected Charge and Single Rate

Sensor single rate is crucial for health of apparatus.

Single rate can foretell problems in charge collection measurement, which can't be detected

efficiency or collected charge or leakage current



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Collected Charge, Single Rates and Efficiency



Sensor single rate at 1 fC threshold is tracking the **median collected charge** well. **Efficiency** at 1fC threshold saturates at much lower voltage and reaches 100% if

signal/threshold S / T > 2,2

Signal/Noise > 9 in the experiment



Determine the required voltage for 98.5% efficiency: "Efficiency Voltage" (e.g. 1 fC threshold)

Collected Charge and Efficiency



Complete universal correlation between collected charge and efficiency



Efficiency Voltage (Threshold Dependence)





Annealing of Efficiency Voltage (@ 1fC) SCIPP 2000 ----- n-on-p MCz p+ 1.3e15 neq ---- p-on-n FZ p+ 3e14 neq 1500 ----- p-on-n FZ pi 6.1e14 neg Efficiency<u>√</u>oltage (V) 00 ----- n-on-p MCz pi 3.8e14 neq -A-n-on-p MCz n 5e14 -A-n-on-n MCz n 1e15 500 0 100 1000 1000d 10 1 Anneal Time @ 60° C (min)

Annealing benign for all but p-on-n FZ



No big difference between proton/pion and neutron irradiation N-on-n MCz shows "typical n-type" annealing, but on a small scale.

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Comparison Efficiency Voltage - Vfd







If one adjust the Efficiency voltage with difference in fluence, the Eff Voltage vs. Anneal curve will be above the Vfd curve, indicating that n-on-p MCz inverts with pion (also proton) irradiation. This is also seen in the Vfd as a function of fluence curve.

Comparison Efficiency Voltage - Vfd



p-on-n FZ p+



Once the Efficiency voltage is scaled with the fluence, it would clearly be much larger than the Vfd for either Vfd fluence, indicating strong inversion of pon-n FZ after proton irradiation

For n-on-p FZ, it can be seen that at a given fluence, the efficiency voltage will be lower than Vfd, indicating no inversion after prtoton irradiation. This is consistent with the p-on-n FZ being inverted (bulk becomes more p-type)



What to do with C-V Measurements?



"C-V"

means here " learn something about the depletion of the sensor, to be used to predict CCE or learn something about the state of the sensor when compared to CCE"

At least 4 diferent approaches:

- 1. Measure C-V at 10 kHz and low temperature: wrong
- 2. Measure C-V at R.T and 10 kHzless less wrong, good convention (Gregor showed is ~ ok for diodes: Vdep(CEE) =Vdep(CV) within 200V)
- 3. Measure C-V at lower temperature, adjust frequency C-V(f,T) better
- 4. Measure Admittance, extract the width of the space charge region best?

C-V(f,T)



3. Measure C-V at lower temperature, adjust frequency

Measure C-V at lower temperature, adjust frequency to match according to the emission coefficient C-V(f,T). (usual current temperature dependence)

M.K. Petterson, et al., RRESMDD06, Nucl. Inst. Meth. A 583, 189(2007)

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Frequency to be used at temperature T to best approximate the 10 kHz RT C-V characteristics

<i>T</i> (°C)	Frequency (Hz)	
20	104	
10	4×10^{3}	
0	1.5×10^{3}	
-10	450	
-20	200	
-30	50	



Fig. 4. Median value of the collected charge in an irradiated n-type MCz Si microstrip detector W187-S2 (Fluence of irradiation $1.7 \times 10^{14} \, \text{cm}^{-2}$ 1 MeV n_{eq}), after 5 min annealing at 60 °C, compared to the reciprocal capacitance normalised on the collected charge measured at different temperatures with test signal of different frequencies.

Admittance



4. Measure Admittance, extract the width of the space charge region $Y = Z^{-1} = G_n + j\omega C_n$

Introduce Debye length to characterize non-abrupt junction(s) Since trapping and de-trapping is important, measure both Capacitance C and Conductance G as a function of temperature T and frequency ω

$$C_{d}\left(V_{dep}\right)= \mathcal{E}\!A/(W-L_{D})$$

Frequency dependence of conductance reveals dynamics of trapping C, Betancourt , et al., RRESMDD08, IEEE 2009, Senior Thesis Measured and simulated C and G/ω as a function of frequency for a pion irradiated n-type FZ detector taken at 100V and 22 degrees C



Results of Admittance Measurement



Extracted depth of the space charge region from CCE andAdmittance

p-on-n FZ pion irradiated sensor and diode



n-on-p MCz neutron irradiated Sensor and diode



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Results of Admittance Measurement



Depleted depth of the space chare region for various pion detectors Extracted from Admittance measurements



Clustersize and Efficiency

Cluster size is given by the "Cluster Ratio" = # of clusters with multiple strips / # of clusters with one strips



Good Correlation, p-on-n FZ inverted.



Clustersize and Efficiency



Clustersize and Efficiency

All p-type ~ same ?



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Conclusions



For charge collection studies, the health of the system can be determined by monitoring the singles rate. It signals breakdown and thus unphysical behavior even before the leakage current or the collected charge do it.

In order to quantify the performance, we introduce the "efficiency voltage" as the bias voltage at which the efficiency reaches 100%. Very little annealing is observed, with the exception in p-on-n FZ.

The efficiency voltage for p-type material is about the same for FZ and MCz in this fluence range.

Comparison between efficiency voltage for SSD and full depletion voltage Vfd of diodes permits insight into the fact of "inversion".

The correlation of the efficiency with the clustersize is uniform across many different sensor types, particle species during irradiation, and anneal steps (with the exception of the p-on-n FZ sensors,)

Admittance allows extraction the depth of the depleted region of irradiated sensors



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